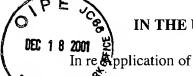
Docket No.: 5918/04/FPS/MMCS/APC/DV

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Technology Center 2100

Arulkumar P. Shanmugasundram et al.

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: Examiner:

For: FEEDBACK CONTROL OF A CHEMICAL MECHANICAL POLISHING DEVICE PROVIDING MANIPULATION OF REMOVAL RATE PROFILES

REQUEST FOR CHANGE OF CORRESPONDENCE ADDRESS

Honorable Commissioner for Patents Washington, D.C. 20231

Sir:

The undersigned Principal Attorney of record hereby requests that **all correspondence** for the above-identified patent application be directed to the following address:

Patent Counsel, MS/2061 Legal Affairs Department Applied Materials, Inc. P.O. Box 450A Santa Clara, CA 95052

Respectfully submitted,

HALE AND DORR LLP

Scott M. Alter

Registration No. 32,879

1455 Pennsylvania Avenue, NW Washington, DC 20004

Tel. 202-942-8428

Fax 202-942-8484 Date: \\2 \(\frac{1}{2} \) 0